


<b>Search Notes</b>  	<b>Application/Control No.</b>  10540500	<b>Applicant(s)/Patent Under Reexamination</b>  KIM, YEE-HYENG
	<b>Examiner</b>  Fonseca, Jessie	<b>Art Unit</b>  3637

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
52	518, 519, 523, 530, 538, 536, 540, 506.01, 506.05, 390	5/10/2007	JF

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Consulted Michael Safavi with regards to a search in class 52	5/10/2007	JF

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>